NOV 10 '03 08:09 - FROM: TUNG ASSOCIATES

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U.S.S.N. 09/941,537

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1756

Applicants: Chen et al.

Examiner: J. S. Ruggles

Serial No.: 09/941,537

Filed: 08/29/2001

In Response to Office Action

Dated: 09/11/2003

For: METHOD FOR REDUCING LIGHT REFLECTANCE IN A PHOTOLITHOGRAPHIC

DUAL DAMASCENE TRENCH PATTERNING PROCESS

Attorney Docket No.: 67,200-477

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Request For Reconsideration

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 09/11/2003, Applicants respectfully request entry of the following amendments to either place the claims in condition for allowance or place the claims in better form for appeal. Please consider the following remarks.

PAGE 2/27 * RCVD AT 11/10/2003 7:49:53 AM [Eastern Standard Time] * SVR:USPTO-EFXRF-1/0 * DNIS:8729311 * CSID:12485404035 * DURATION (mm-ss):05-24